



**ELECTRONIC COPY**

LG667458189  
Report verification at igi.org



December 2, 2024

IGI Report Number **LG667458189**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **MARQUISE BRILLIANT**

Measurements **13.10 X 6.56 X 4.18 MM**

**GRADING RESULTS**

Carat Weight **2.07 CARATS**

Color Grade **G**

Clarity Grade **VS 1**

**LABORATORY GROWN DIAMOND REPORT**

December 2, 2024

IGI Report Number **LG667458189**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **MARQUISE BRILLIANT**

Measurements **13.10 X 6.56 X 4.18 MM**

**GRADING RESULTS**

Carat Weight **2.07 CARATS**

Color Grade **G**

Clarity Grade **VS 1**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

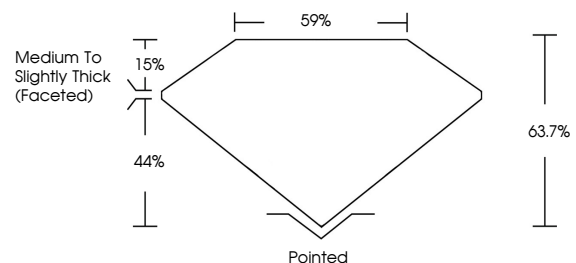
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG667458189**

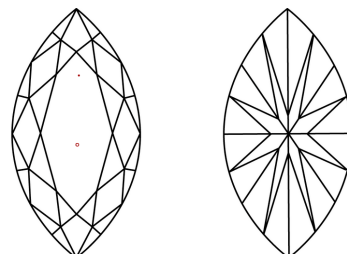
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

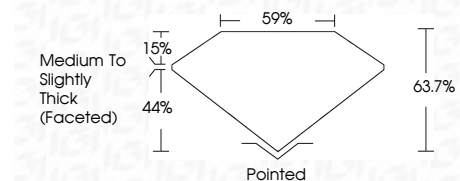
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG667458189**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



December 2, 2024  
IGI Report No LG667458189  
**MARQUISE BRILLIANT**

13.10 X 6.56 X 4.18 MM

2.07 CARATS  
Color Grade **G**

Clarity Grade **VS 1**

Depth **63.7%**  
Table **6%**

Medium to Slightly Thick (Faceted)

Pointed  
Culet **EXCELLENT**

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG667458189**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa